To the Honorable Commissioner of Patents:

1. Name and Address of Conveying Party(ies):
   CVC, Inc.
   525 Lee Road
   Rochester, New York 14603
   [Corporation/State: Delaware]

   Additional name(s) of conveying party(ies) attached?
   Yes [X] No

3. Nature of conveyance:
   [X] Assignment
   [ ] Security Agreement
   [ ] Change of Name
   [ ] Other

   Execution Date: February 3, 2000

4. Application number(s) or patent number(s):
   If this document is being filed together with a new application, the execution date of the application is:
   A. Patent Application No.(s)
      09/067,142

   Additional Numbers attached?
   [X] Yes

5. Name and address of party to whom correspondence concerning document should be mailed:
   Name: Robert W. Holland
   Internal Address: BAKER BOTT'S L.P.
   Street Address: 2001 Ross Avenue
   City: Dallas
   State: Texas
   Zip: 75201-2980

6. Total number of applications and patents involved: 1

7. Total Fee (37 CFR 3.41): $360.00
   Enclosed
   [X] Authorized to be charged to deposit account

8. Deposit account number:

   (Attach Duplicate Copy of this page if paying by deposit account)


   To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

   [Signature]
   Robert W. Holland
   Name of Person Signing

   February 24, 2000
   Date

   OMB No. 0651-0011 (exp. 4/94)

   Do not detach this portion

Mail documents to be recorded with required cover sheet information:
Comptroller of Patent and Trademarks
Box Assignments
Washington, D.C. 20231

Public burden reporting for this sample cover sheet is estimated to average about 3 minutes per document to be completed, including time for reviewing the document and gathering the data needed, and completing and reviewing the sample cover sheet. Send comments regarding this burden estimate to the U.S. Patent and Trademark Office, Office of Information Systems, PA30-000C, Washington, D.C. 20231, and to the Office of Management and Budget, Paperwork Reduction Project, 0651-0011, Washington, D.C. 20573.
U.S. Patent and Trademark Office

Recordation Form Cover Sheet - Form PTO-1595 (01/31/92)
Patents Only
Page 2

Attorney's Docket: 021208.0101

Section 4.A. - Patent Application Number(s)

Additional numbers:

09/146,486
09/113,852
09/484,816
09/484,778
09/487,393
09/484,821
PCT/US99/08994
PCT/US99/15583
PATENT ASSIGNMENT

WHEREAS, CVC, Inc. (hereafter "Assignor"), a Delaware corporation, having an address of 525 Lee Road, Rochester, New York 14603, is the owner of the U.S. and foreign patent applications set forth on Exhibit A hereto and the inventions described and claimed therein (hereafter the "Patent Property"); and

WHEREAS, CVC Products, Inc. (hereafter "Assignee"), a Delaware corporation, having an address of 525 Lee Road, Rochester, New York 14603, desires to acquire all right, title and interest in and to the Patent Property.

NOW THEREFORE, for good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, Assignor does hereby sell, assign, transfer and set over to Assignee, all its right, title and interest in and to the Patent Property, as well as all provisionals, continuations, divisions, and continuations-in-part of said Patent Property, and all reissues and extensions thereof, the same to be held and enjoyed by Assignee for its own use and benefit, and for the use and benefit of its successors, assigns, or legal representatives, to the end of the term or terms for which such Patent Property may be granted or reissued, as fully and entirely as the same would have been held and enjoyed by Assignor if this assignment and sale had not been made.

Assignor also assigns to Assignee, all right, title and interest in and to the inventions disclosed in said Patent Property throughout the world, including the right to file applications and obtain patents, utility models, industrial models and designs for said Patent Property in its own name throughout the world, including all rights to publish cautionary notices reserving ownership of said inventions and all rights to register said Patent Property in appropriate registries; and all rights to sue and recover for damages by reason of past infringement of such Patent Property; and Assignor further agrees to execute any and all powers of attorney, applications, assignments, declarations, affidavits, and any other papers in connection therewith necessary to perfect such right, title and interest in Assignee.

Assignor also assigns unto Assignee all claims for damages by reason of infringement prior to the assignment date of the Patent Property throughout the world, with the right to sue for and collect the same for its own use and benefit, and for the use and benefit of its successors, assigns and other legal representatives.

Assignor also will communicate to Assignee any facts known to it respecting any improvements; and, at the expense of Assignee, will testify in any legal proceedings, sign all lawful papers, execute all provisional, divisional, continuation, continuation-in-part, reissue and substitute applications, make lawful oaths and declarations, and generally do everything possible to vest title in Assignee and to aid Assignee to obtain and enforce proper protection for said Patent Property in all countries.

AUS01:193708.1

PATENT
REEL: 010638 FRAME: 0614
IN WITNESS WHEREOF, the parties have caused this Patent Assignment to be executed on the dates and in the capacities shown below.

CVC, Inc.
By: ____________________________
    Mehrdad M. Moslehi
Its: Senior Vice President and Chief Technology Officer
Date: 2/03/2000

CVC Products, Inc.
By: ____________________________
    Mehrdad M. Moslehi
Its: Senior Vice President and Chief Technology Officer
Date: 2/03/2000
STATE OF TEXAS §

COUNTY OF TRAVIS §

Before me, the undersigned, a Notary Public on this day personally appeared MEHRDAD M. MOSLEHI, known to me to be the person and officer whose name is subscribed to the foregoing instrument and acknowledged to me that the same was the act of the said CVC, Inc., a Delaware corporation, and that he had executed the same as the act of such corporation for the purpose and consideration therein expressed, and in the capacity therein stated.

Given under my hand and seal of office this 3rd day of February, 2000.

CORINA Y. HARRISON
NOTARY PUBLIC, STATE OF TEXAS
MY COMMISSION EXPIRES
OCT. 17, 2002

Notary Public in and for the State of Texas

PATENT
REEL: 010638 FRAME: 0616
### U.S. PATENT APPLICATIONS

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<th>Docket No.</th>
<th>Appl. No.</th>
<th>Filing Date</th>
<th>Title</th>
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<td>021208.0157</td>
<td>09/067,142</td>
<td>04/27/98</td>
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<td>Processing Applications</td>
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<td>021208.0202</td>
<td>09/146,486</td>
<td>09/03/98</td>
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<td></td>
<td></td>
<td></td>
<td>on a Substrate</td>
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<td>09/22/98</td>
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### PENDING FOREIGN PATENT APPLICATIONS

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**RECORDED: 02/29/2000**

**REEL: 010638 FRAME: 0617**